



**RESPONSE UNDER 37 C.F.R.
§1.116 EXPEDITED PROCEDURE
EXAMINING GROUP 1763**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Yukio Morishige, et al.	Examiner:	Richard R. Bueker
Serial No.:	10/600,075	Art Unit:	1763
Filed:	June 20, 2003	Docket:	16748
For:	LASER CVD DEVICE AND LASER CVD METHOD	Dated:	August 30, 2006
		Confirmation No.	9161

Mail Stop AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.116

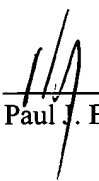
Sir:

In response to the Office Action of May 30, 2006, Applicants respectfully request entry of the following amendments under 37 C.F.R. § 1.116 that are believed to place the Application in condition of allowance.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, Box 1450, Alexandria, VA 22313-1450 on August 30, 2006.

Dated: August 30, 2006



Paul J. Esatto, Jr.